

Notice of References Cited

Application/Control No.

09/600,546

Applicant(s)/Patent Under
Reexamination
CHAPPERT ET AL

Examiner

Martin J Angebrannt

Art Unit

1756

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
	A	US-4551908 ✓	11-1985	Nagasawa et al.	29	571
	B	US-4600488 ✓	07-1986	Imura et al.	204	298
	C	US-				
	D	US-				
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	J	US-				
	K	US-				
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	M	US-				

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	N	62-297458	12-1987	Japan	****	--	--
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	U	Kanayama et al., "Fine Pattern Definition with Atomic Intermixing Induced by Focused Ion Beam and Its Application to X-ray Mask Fabrication", J. Vac Sci. Technol. B, Vol 9(2) pp. 296-301 (4/1991)					
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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	G	US-			
	H	US-			
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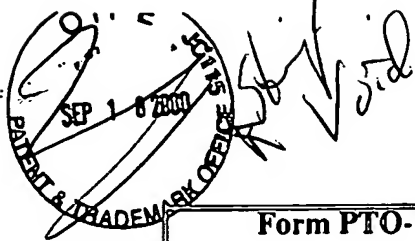
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	N	2773632	07-1999	France	Chappert et al.	***
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	U	Copy of Specification denoted WO 99/35657 in upper left and 1 in upper right.
	V	Copy of specification denoted 2 in upper right hand corner.
	W	
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Form PTO-1449 (Modified)	Atty Docket No. 15675.P322	Serial No. 09/600,546
List of Patents & Publications Statement	Applicant(s): C. Chappert	
(Use several sheets if necessary)	Filing Date: 7/12/00	Group No. 1756

U.S. PATENT DOCUMENTS

Exam. Initials	Document Number	Date	Name	Class	Sub-class	Filing Date (if appropriate)
	AA					
	AB					
	AJ					
	AK					

FOREIGN PATENT DOCUMENTS

Exam. Initials	Document Number	Date	Country	Class	Sub-class	Translation Yes No
JA	AL JP0129699	11/1989	Japan			X
	AQ					

OTHER ART (Including Title, Author, Date, Pertinent Pages, etc.)

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JA	AR Xiao J.Q. et al.: "Effects of ar-Ion implantation and annealing on structural and magnetic properties of CO/PD multilayers" Journal of applied Physics, vol. 76, no. 10, part 02 11/15/94, pages 6081-6083
JA	AS Amaral L. et al.: "Very Thin Fe/Ni modulation multilayer films under ion bombardment" Journal of Applied Physical vol. 81, no. 8, part 02B, April 15, 1997, pages 4773-4775
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JA	AV Schelp L. F. et al.: "Structural and Magnetic Behavior of AR+-Implanted Co/PD Multilayers: Interfacial Mixing" Journal of Applied Physics vol. 75, no. 10, part 01, May 15, 1994

Examiner: JA/KA

Date Considered: 3/04/05
4/14/01

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